



TFW

PATENT

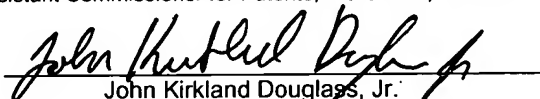
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Applicant: Ritter  
Serial No.: 10/809,624  
Filed: 03.25.04  
Title: Non-Uniformly Polished Scintillation Crystal For A  
Gamma Camera

Docket No.: 2004P02001 US  
Examiner: To Be Assigned  
Group Art Unit: To Be Assigned  
Dated: 07.Jun.2004

CERTIFICATE OF MAILING

I hereby certify that correspondence is being deposited on  
07.Jun.2004 with the U.S. Postal Service with sufficient postage as  
first class mail on the below-indicated date in an envelope addressed  
to: Assistant Commissioner for Patents, Alexandria, VA 22313-1450

  
John Kirkland Douglass, Jr.

Mail Stop PGPUB  
Commissioner for Patents  
P.O.Box 1450  
Alexandria, VA 22313-1450

LETTER TO OFFICIAL DRAFTSPERSON

Sir:

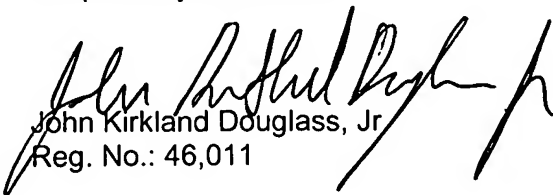
Pursuant to M.P.E.P. Section 608.02, enclosed please find 4 sheet(s) of formal drawings in the referenced case. These are formal versions of the informal drawings filed with the application.

The following applies hereto:

- ☒ No change has been made to the drawing(s) during the prosecution of this case.
- ☐ Change(s) approved by the Examiner in the Notice of Allowability have been incorporated herein.
- ☐ Corrections made herein are informalities noted by the Draftsman on Form PTO-948.
- ☐ Reference is made to the Office Action/Notice of Allowability dated

Passage of this case to issue is respectfully requested.

Respectfully submitted,

  
John Kirkland Douglass, Jr.  
Reg. No.: 46,011

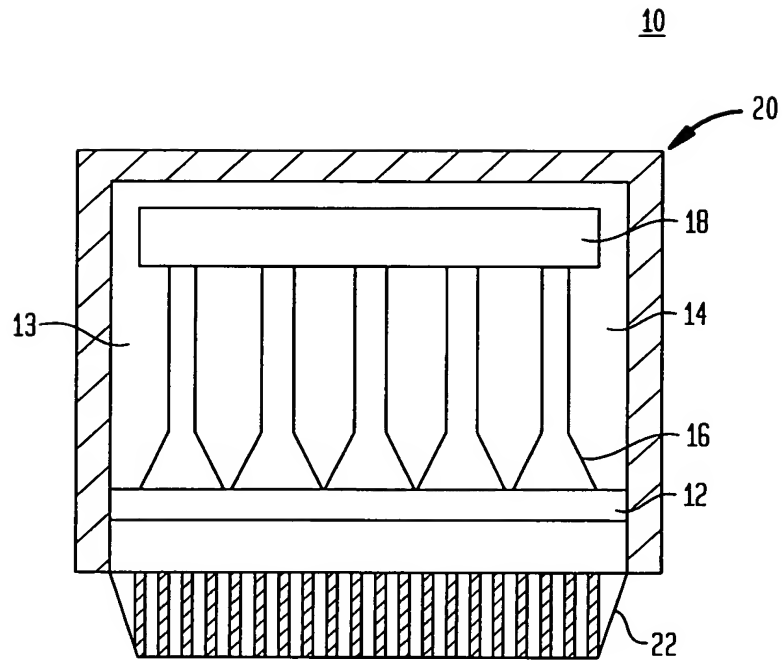
Siemens Corporation  
Intellectual Property Department  
170 Wood Avenue South  
Iselin, NJ 08830  
Tel.No.: +1 (732) 321 3046



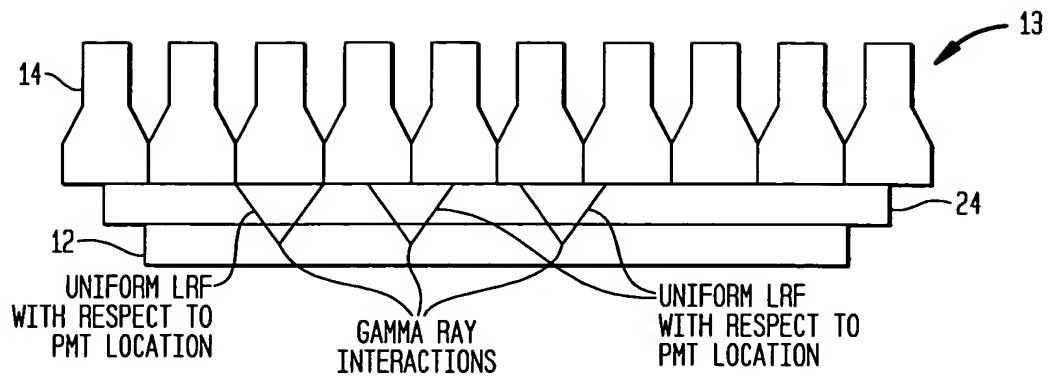
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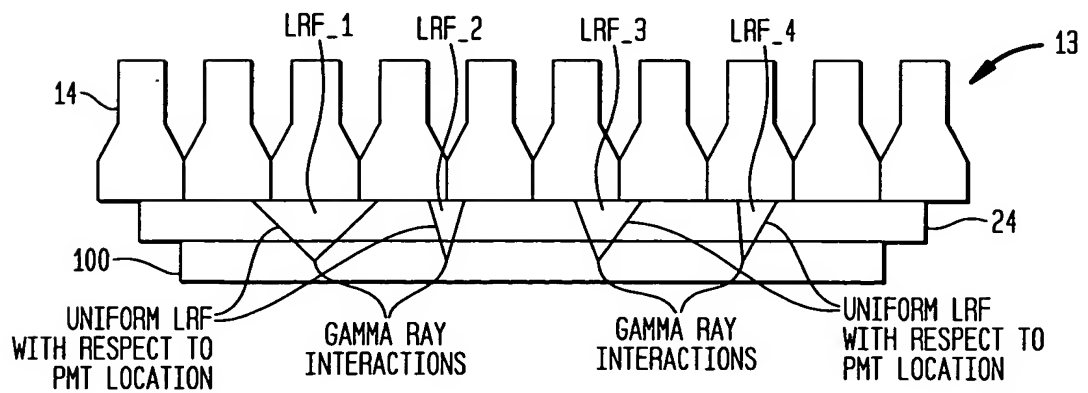
**FIG. 1**  
(PRIOR ART)



**FIG. 2**  
(PRIOR ART)



**FIG. 4**



**FIG. 3**

100

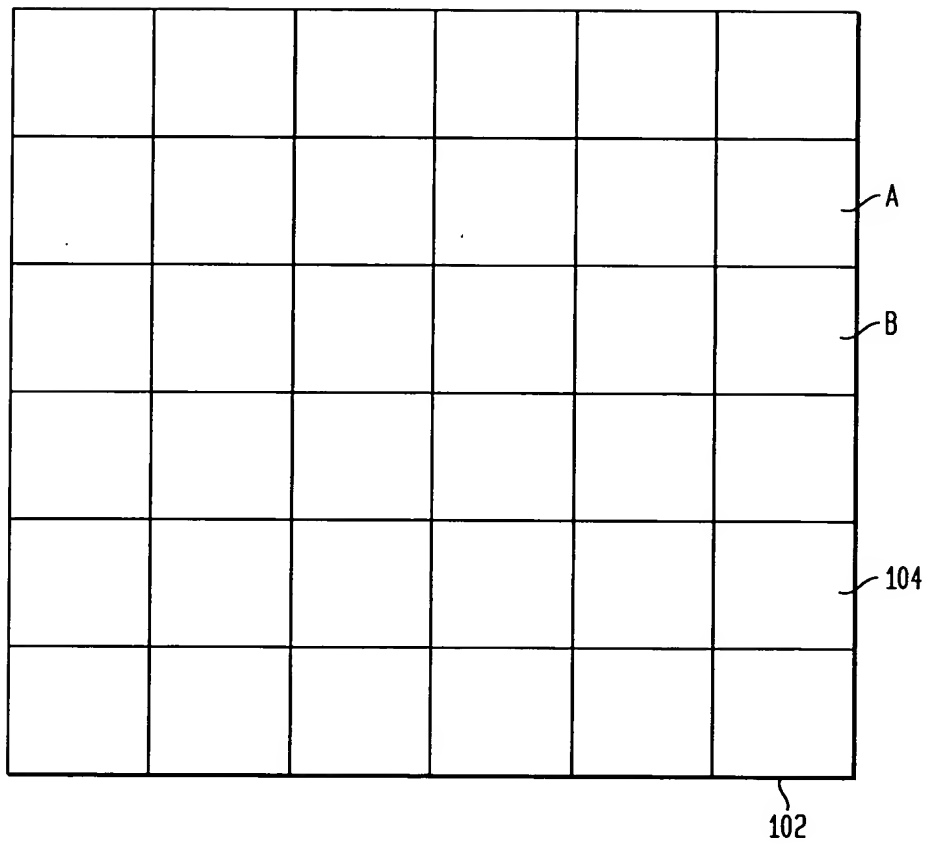


FIG. 5

